

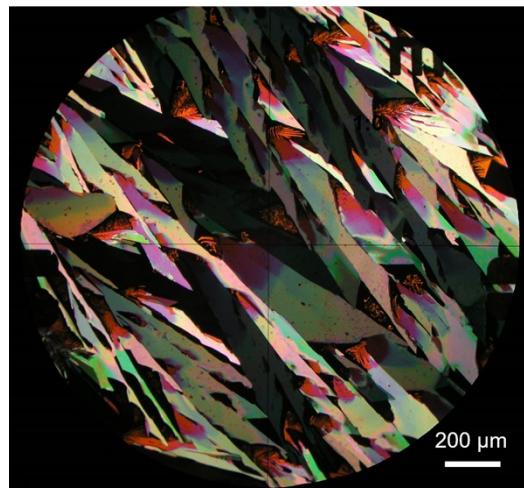
## **Organic transistors based on airbrushed small molecule- insulating polymer blends with mobilities exceeding 1 cm<sup>2</sup>/Vs**

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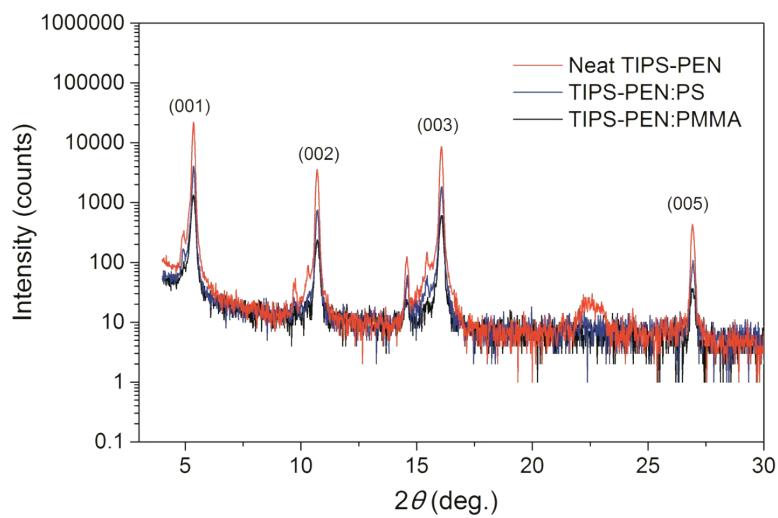
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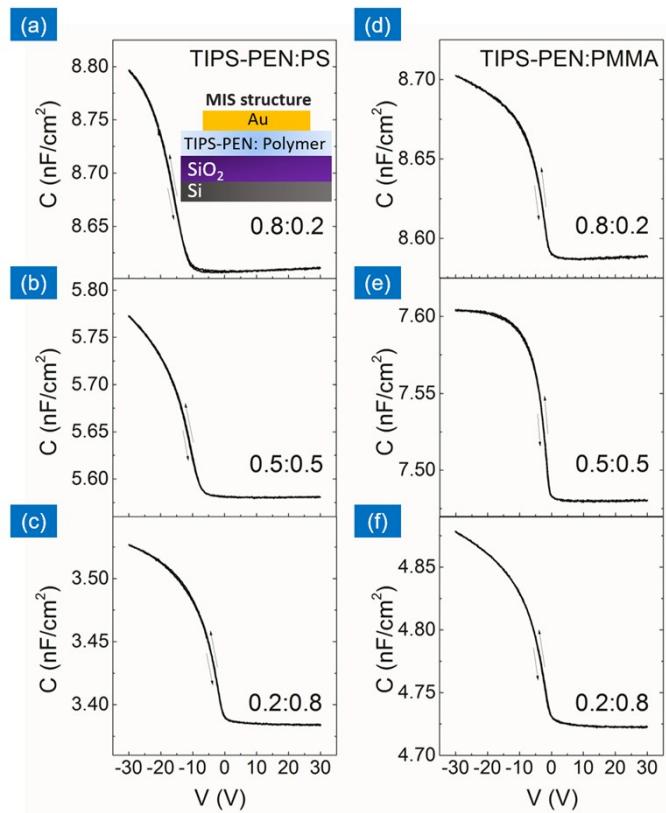
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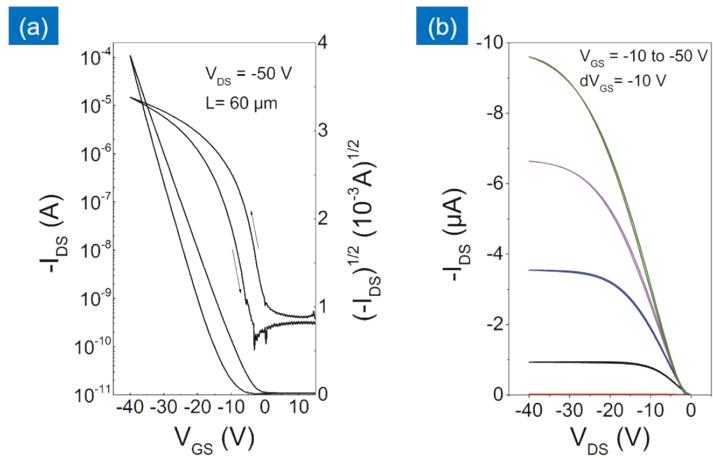
**Fig. S1** Polarized optical microscopy (POM) image of airbrushed TIPS-PEN film on HMDS treated SiO<sub>2</sub>/Si substrates.



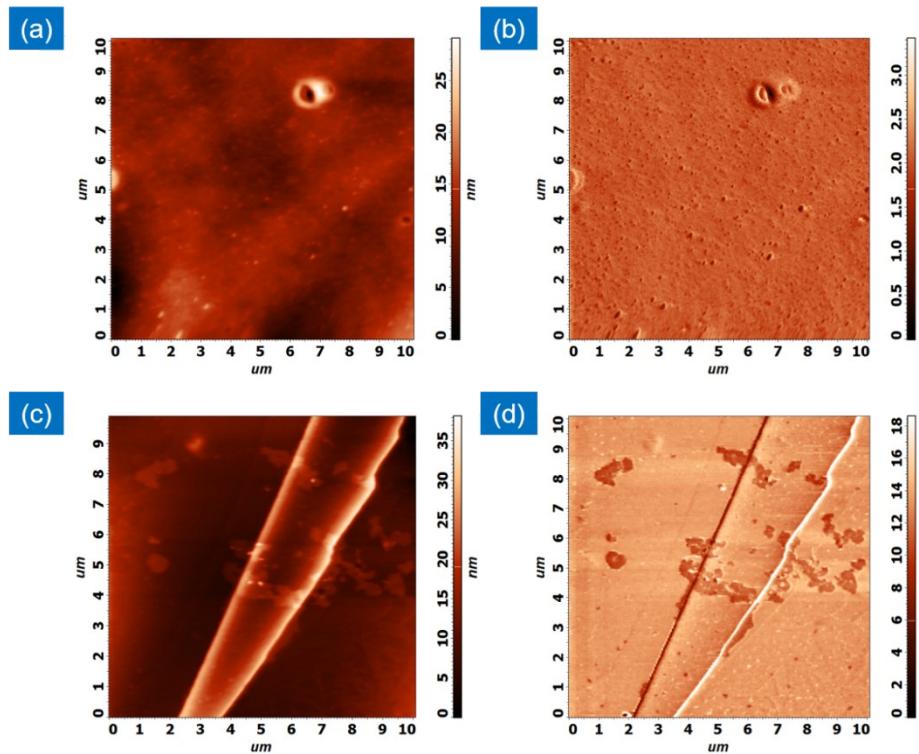
**Fig. S2** Comparative XRD spectra of neat TIPS-PEN, TIPS-PEN :PMMA, TIPS-PEN :PS airbrushed films.



**Fig. S3** Capacitance-voltage (C-V) diagrams of MIS capacitors based on airbrushed (a-c) TIPS-PEN :PS and (d-f) TIPS -PEN:PMMA blends for the different ratios respectively.



**Fig. S4** (a) Transfer and (b) output I-V characteristics of airbrushed OFETs based on neat TIPS-PEN.



**Fig. S5** AFM topography and phase images of the (a,b) TIPS-PEN :PS and (c,d) TIPS-PEN :PMMA airbrushed films after selective etching of TIPS-PEN using cyclohexane. The weight fraction ratio of the blends is 0.8:0.2.